

3724

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Vishwanathan et al.

Serial No.: 09/608,537

Filing Date: 6/30/2000

Title: POLISHING PADS FOR CHEMICAL MECHANICAL PLANARIZATION

Attorney Docket No.: 126

COMMISSIONER FOR PATENTS
Washington, D.C. 20231



Examiner: T. Eley

Group Art Unit: 3724

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STATEMENT UNDER 37 CFR 1.97(e)

Sir:

The undersigned hereby certifies that either:

- Each item of information contained in the Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application, not more than three months prior to the filing of the statement, or
- No item of information contained in the Information Disclosure Statement
- was cited in a communication from a foreign patent office in a counterpart foreign application, and
- to the knowledge of the undersigned, after making reasonable inquiry, was known to an individual designated in 37 CFR 1.56 (c) more than three months prior to the filing of the Information Disclosure Statement.

Respectfully submitted,

Vishwanathan et al.

By Kenneth A. Benson

Kenneth A. Benson
Agent for Applicant(s)
Reg. No.: 27971

Date of Deposit: June 8, 2002

Typed Name: Barbara A. Wiley

Signature: Barbara A. Wiley

Date: June 8, 2002

Telephone No.: 302-366-0500